

Attorney Docket No. 040008-0307317
Client Reference: OG03-021

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: JAE WON HAN

Application No.:

Confirmation

No:

Filed: December 30, 2003

Group No.:

Examiner

For: METHOD OF FABRICATING METAL INTERCONNECTION OF SEMICONDUCTOR
DEVICE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

APPLICATION DATA SHEET
37 C.F.R. § 1.76

BIBLIOGRAPHIC DATA

1. Applicant information

First applicant: JAE WON HAN
Citizenship: Republic of Korea
Residence: Bucheon-si, Gyeonggi-do, Korea

2. Correspondence information

Correspondence for this application should be addressed as follows:

Customer No.: 00909

3. Application information

Title of Invention: METHOD OF FABRICATING METAL INTERCONNECTION OF
SEMICONDUCTOR DEVICE

Docket number assigned to this application: 040008-0307317

Suggested Classification: Class:

Subclass:

Technology Center to which subject matter is assigned:

Total number of drawing sheets: 4

Type of application: Utility

Application is to be published. Suggested drawing figure for publication:

Secrecy order under § 5.2:

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

4. Representative information

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

5. Foreign priority information

Foreign priority is claimed for this application as follows:

Country: Republic of Korea
Application No.: 10-2003-0041022
Filing Date: June 24, 2003
Status: Pending

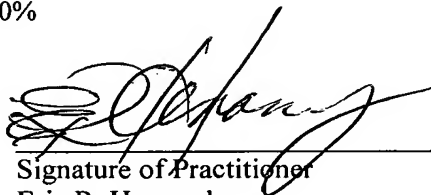
6. Assignee information

The assignee(s) of this application is/are:

Anam Semiconductor Inc.
891-10 Daechi-dong, Gangnam-gu
Seoul, 135-523
Korea
Extent of interest of assignee in application: 100%

Date: December 30, 2003

PILLSBURY WINTHROP LLP
P.O. Box 10500
McLean, VA 22102
Customer No. 00909



Signature of Practitioner
Eric R. Hernandez
Registration No. 47641
(703) 905-2088